

64

<b>IDS - INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)	Docket Number (Optional) <b>14846-17</b>	Application Number <b>60/459,328</b>
Applicant(s) <b>L. Love, et al.</b>		
Filing Date <b>04/01/2003</b>		Group Art Unit

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
MEK	A	US 5,768,119	6/16/1998	Havekost, et al.			
MEK	B	US 6,046,742	4/4/2000	S. Chari			
MEK	C	US 6,184,996 B1	2/6/2001	S. Gase			
MEK	D	US 5,325,527	6/28/1994	R. Cwikowski, et al.			
MEK	E	US 5,553,235	9/3/96	J. N. Chen, et al.			
MEK	F	US 5,790,809	8/4/1998	R. Holmes			
MEK	G	US 5,946,458	8/31/1999	P. Austin, et al.			
MEK	H	US 5,999,179	12/7/1999	M. Kekic, et al.			
MEK	I	US 6,288, 790 B1	9/11/2001	K. Kishore, et al.			
MEK	J	US 6,332,161 B1	12/18/2001	G. Sasson			
MEK	K	US 6,453,127 B2	9/17/2002	C. Wood, et al.			

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
MEK	1	Strict Read Order Control for a Queing System,spi.org
MEK	2	Beginning of Viewing Informationa and Viewing Basic Information about a Print from 5 Managing Print Queues,spi.org

EXAMINER <b>/Michael Keefer/</b>	DATE CONSIDERED <b>01/03/2007</b>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**INFORMATION DISCLOSURE CITATION**  
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Group Art Unit

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
MEK	L	US 6,470,384 B1	10/22/2002	E. O'Brian, et al.			
MEK	M	US 6,477,590 B1	11/5/2002	U. Habusha, et al.			
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MEK	O	US 6,185,613 B1	2/6/2001	T. Lawson, et al.			

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

MEK	3	x4queview spi.org

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